



### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

## In re Application of:

Dennison et al.

Serial No.: 10/020,741

Filed: December 12, 2001

Patent No.: 5,270,241

Issued: December 14, 1993

For: OPTIMIZED CONTAINER-STACKED CAPACITOR DRAM CELL UTILIZING SACRIFICIAL OXIDE DEPOSITION AND CHEMICAL MECHANICAL POLISHING

Confirmation No.: 2283

Examiner: T. Nguyen

Group Art Unit: 2813

Attorney Docket No.: 3259.1US

(91-473.02/RE)

#### CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria A& 22313-1450.

**Φ** 

July 18, 2003 Date

Signature

Doreen Neumann
Name (Type/Print)

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JUL 29 2003

#### RESPONSE

Mail Stop NON-FEE AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are filed in response to the Examiner's remarks in the Office Action mailed April 18, 2003, the three-month shortened statutory period for response to which expires on July 18, 2003.

# Serial No. 10/020,741

**Listing of the Claims** are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 6 of this paper.